Form PTO-1449					ATTY. DOCKET NO. 0020-5197P		APPLICATION NO. NEW		
<ul> <li>INFORMATION DISCLOSURE CITATION</li> <li>IN AN APPLICATION</li> </ul>					APPLICANT FUJISAWA, Koichi et al.				
	(	Use several sheets	PILING DATE November 20, 2003		GROUP				
U.S. PATENT DOCUMENTS									
EXAMINER INITIAL	DOCU	MENT NUMBER	Kind	DATE	NAME	CLASS	SUB CLASS	FILII IF ADD	G DATE
a	<u> </u>	US 4,683,257		1987-07-28	Kakiuchi et al.	524	432		
an	US 4,929,678			1990-05-29	Hamada et al.	525	193		
B	ບຣ	4,955,613		1990-09-11	Gendreau et al.	273	218		
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FOREIGN PATENT DOCUMENTS									
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1	JР	6-80123	B2	1994-10-12	JAPAN				X
m	JP	2644226	B2	1997-05-02	JAPAN		÷		义
m	JP	2678240	B2	1997-08-01	JAPAN				X
pr	JР	11-319148	A	1999-11-24	JAPAN		1	ABS	
Bu	JР	2001-149502	A	2001-06-05	JAPAN			ABS	
a	JP	2001-149503	A	2001-06-05	JAPAN			ABS	
	- <del>1</del> p	2001-149505		2001-06-05	- JAPAN			- <del>VB</del> C.	
m	JP	2001-149506	A	2001-06-05	JAPAN			ABS	
M	JP	2001-149507	A	2001-06-05	JAPAN			ABS	
pr.	JP	2001-149508	A	2001-06-05	JAPAN			ABS	
OTHER	DOCUM	MENTS (Include Name	of the authorage (s). vol	or (in Capital Letters), to	itle of the article (when appropriate, city and/or country where	riate), tit	le of the ite	m (book, s	negazine,
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